



Paper number 20051024

<b>FORM HDP-1449 (Based on Form PTO-1449)</b>  <b>PATENT AND TRADEMARK OFFICE</b> <b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)  Sheet 1 of 1	ATTORNEY DOCKET NO.	SERIAL No.
	2115D-000939/DVD	09/775,069
	APPLICANT	
	Gerard A. Mourou	
	FILING DATE	GROUP
	February 1, 2001	1725

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	/G.E./	5,637,244	06/10/1997	Erokhin	<del>          </del>	

FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes No
1.	/G.E./	JP 403 216 287 A	09/24/1991	Japan	<del>          </del>	Abstract

Examiner: /Geoffrey Evans/	Date Considered: 07/09/2007
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Paper number 20060324

<b>PATENT AND TRADEMARK OFFICE</b> <b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)  Sheet 1 of 1	FORM PTO-1449 (Based on Form PTO-1449)	
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FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No
1.	/G.E./	JP 03216287 A	09/24/1991	Japan	_____	Abstract	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.	/G.E./	Mannion et al., "Ablation Thresholds in Ultrafast Laser Micro-Machining of Common Metals in Air, Proceedings of SPIE, Vol. 4876 (2003), pages 470-478.
2.	/G.E./	S. Amoroso et al., "Characterization of Laser-Ablation Plasmas", J. Phys. B: At. Mol. Opt. Phys. 32 (1999) R131-R172, section 2.1.1.
3.	/G.E./	Kautek et al., Laser Ablation of Dielectrics with Pulse Durations Between 20 fs and 3 ps, Appl. Phys. Lett. 69(21), November 18, 1996, pages 3146-3148.
4.	/G.E./	J. Bonse et al., Ultrashort-Pulse Laser Ablation of Indium Phosphide in Air, Appl. Phys. A Volume 72, Issue 1, pages 89-94 (2001)
5.	/G.E./	S. Preuss et al., Time Resolved Dynamics of Subpicosecond Laser Ablation, Appl. Phys. Lett, Vol. 62, No. 23, June 7, 1993
6.	/G.E./	Schwab et al., Femtosecond-Excimer-Laser Patterning of YBa2 Cu3 O7 Films, Appl. Phys. A, Volume 53, (1991), pages 282-283.
7.	/G.E./	Chen et al., Generation of Submicron Surface Gratings on LiNbO3 by Ultrashort UV Laser Pulses, Appl. Phys. A, Volume 65, Pages 517-518 (1997).

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